

Self-propagating combustion Simulation of sputter-deposited Nano-Energetic Multilayer Films

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Introduction

Nano reactivity multilayers films (nRMFs) are 2-Dimansion nanoenergetic materials that is wildly used in energetic chips, but it was found that the released heat of RMFs is less than their theoretical value, and the released heat depended on the thickness of reactants or layers. The interface chemical pre-reactions between two boundary layers was considered to be decreasing reason of released heat. The dependence of released heat on the thickness of layer will be researched to find the interface reaction mechanism of Al/Ni, Al/Ti multilayer films by DSC and XRD.

Before reaction, the compositions of Al/Ni nRFMs include Al(111), Al(222), Ni(111), Ni(200), but the diffraction peak of AlxNiy (AlNi(110)) does not confirmed, since it overlaps with the diffraction peak of Ni(111). After reaction, the compositions are AlNi(100), AlNi(110), AlNi(200),

	AlNi(211).	exothermic			ATTIZOON ATTIGON
		200	400	600	800
000		Al Ti 200an Al Ti 200an Al Ti 20an	L ⁱⁿ	C 1000	
	30 60	90			Diffraction angle 2((1)

XRD analyzed results of initial Al/Ni nRFMs are Al(111), Al(222), Ti(100), Ti(110), but because AlTi(111) peak overlaps Al(111) peak, AlxTiy does not been confirmed. After reaction, XRD analyzed results of reacted Al/Ti nRMFs show that the compositions are AlTi(001), AlTi(111), AlTi(002), AlTi(200), AlTi(202), AlTi(220), AlTi(311), AlTi(222), in which AlTi(111) is main reacted product.

Stoichiometric nRMFs

The stoichiometric reactants are required to design high exothermal NEML. The ratio or thicknesses of two reactants can be calculated in Equ

$$\frac{H_1}{H_2} = \frac{m_1 \rho_2}{m_2 \rho_1} = \lambda_{12} \frac{M_1 \rho_2}{M_2 \rho_1}$$

Reactivity of Nano RMFs



Conclusion

Some chemical pre-reactions at interface of reactivity multilayer films (RFMs) are avoided, that will develop a pre-reaction layer between two boundary surfaces of reactants and let the reaction heat of RFMs decrease. The XRD analyzed results of Al/Ni, Al/Ti shown that there is no obvious evidence of pre-reaction layer, such as AlxNiy, but some cases are overlapping XRD peaks of reactants and pre-reaction products. That is to say the possible pre-reaction layer is existed. DSC analyzed supported the view of pre-reaction. The heat of reaction depends on the thickness of reactant layers, in which the thinner reactant layer, the less reaction heat of RMFs. A simple equation is derived to calculate the thickness of prereaction by the experimental data of RFMs reaction heat